



*EF*

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Takeshi Kamimura et al.

Group Art Unit: 2182

Serial No. 11/505,267

Examiner: To Be Determined

Filed: August 16, 2006

For: SEMICONDUCTOR STORAGE DEVICE AND STORAGE SYSTEM

Attorney Docket No. 14008.003

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450 on:

September 26, 2006

Date of Deposit

Christopher J. Fildes

Registered Attorney

*Chris J. Fildes*  
Signature

DRAWING TRANSMITTAL LETTER

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Attention: CHIEF DRAFTSPERSON

Sir:

We are transmitting herewith 5 pages of replacement drawings to replace the informal drawings used for filing purposes for the above referenced application.

Respectfully submitted,  
Takeshi Kamimura et al.  
Fildes & Outland, P.C.

*Chris J. Fildes*  
Christopher J. Fildes, Attorney  
Registration No. 32,132  
20916 Mack Avenue, Suite 2  
Grosse Pointe Woods, MI 48236  
(313) 885-1500